

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: David H. Quach and Jun Zhao

Serial No.: Filed: Herewith

Grp. Art Unit: Examiner: Not Known

Title of Application: Electron Beam Treatment Apparatus

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

SIR:

Information Disclosure Statement under 37 CFR 1.98

Applicant respectfully requests that the references listed on the attached form PTO-1449 be considered in the examination of the above-identified application. The following listing shall not be construed as a representation that no other art than that identified exists, or that each of the references is prior art.

Dated: Feb. 12, 2004

Respectfully submitted,

By Michael B. Einschlag

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FORM PTO-1449								Docket Number (Optional) 008515/DSM/LOW K/JW		Application Number			
INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)								Applicant(s): David H. Quach and Jun Zhao					
								Filing Date		Group Art Unit			
U.S. PATENT DOCUMENTS													
EXAMINER INITIAL	DOCUMENT NUMBER				DATE		NAME			CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
	5	0	0	3	1	7	8	3/26/91	Livesay	250	492.3		
	6	4	0	7	3	9	9	6/18/02	Livesay	250	492.3		
	DOCUMENT NUMBER				DATE		COUNTRY			CLASS	SUBCLASS	Translation YES NO	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)													
EXAMINER								DATE CONSIDERED					
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.													

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